



Attorney's Docket No. 1015290-000500

Patent IRW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

MAIL STOP AF

Si Yi Li et al.

Group Art Unit: 1763

Application No.: 09/820,695

Examiner: ALLAN W OLSEN

Filed: March 30, 2001

Confirmation No.: 4162

Title: METHOD OF PLASMA ETCHING LOW-K DIELECTRIC MATERIALS

NOTICE OF APPEAL

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

All finally rejected claims in the decision of the Primary Examiner dated October 25, 2006 are hereby appealed to the Board of Patent Appeals and Interferences.

- ☐ The appeal fee was previously paid on _____. Therefore, no appeal fee is now required.
- ☐ Enclosed is the appeal fee of: ☐ \$ 500 ☐ \$ 250
- ☐ Charge _____ to Deposit Account No. 02-4800 for the fee due.
- ☐ A check in the amount of _____ is enclosed for the fee due.
- ☒ Charge \$ 500.00 to credit card. Form PTO-2038 is attached.
- ☐ A Petition for Extension of Time is enclosed.
- ☒ Pre-Appeal Brief Request for Review attached.

The Director is hereby authorized to charge any appropriate fees under 37 C.F.R. §§ 1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 02-4800. This paper is submitted in duplicate.

Respectfully submitted,

BUCHANAN INGERSOLL & ROONEY PC

Date: January 19, 2007

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